

PATENT  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

November 9, 2006

In re the application of:

S. Panda et al. Docket No. 175P012

Filed: 11/25/2003 Art Unit: 1765

Serial No.: 10/721,657 Examiner: Lan Vinh

For: Method of Processing Wafers With Confirmation No. 7420  
Resonant Heating

**REPLY TO NON-FINAL OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated June 29, 2006 and identified as Paper No. 062006, please consider the following remarks.

**Remarks/Arguments** begin on page 2 of this paper.